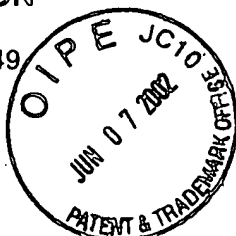


<b>INFORMATION DISCLOSURE CITATION</b>  PTO-1449	ATTORNEY'S DOCKET NO.:  99-1CIP1DIV2	APPLICATION NO.:  09/728,263
	APPLICANT: Bergh, et al.	
	FILING DATE: November 28, 2000	GROUP: 1764



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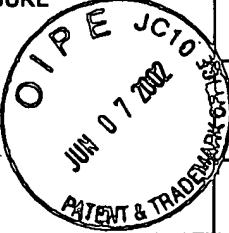
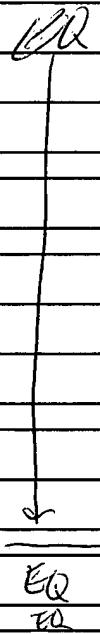
### US PATENT DOCUMENTS

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	5,534,328	7/9/96	Ashmead et al.	428	166	12/2/93
	5,593,642	1/14/97	DeWitt et al.	422	131	6/5/95
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	DD 234 941 A1		Germany		No	
BU	DE 196 32 779 A1		Germany	G01N 35/00	Yes	
	DE 198 05 719 A1		Germany	B01J 35/04	Yes	
	DE 198 06 848 A1		Germany	B01J 35/02	Yes	
	DE 198 09 477 A1	9/16/99	Germany	G01N 31/10	Yes	3/6/98
	DE 198 55 894 A1		Germany	B01J 35/04	No	
	DE 27 14 939 B2		Germany		No	
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	WO 98/16949	4/23/98	WIPO	H01J 49/40	Yes (Ev n pages only)	9/26/97
	WO 99/41005	8/19/99	WIPO	B01J 19/00	Yes	2/11/99

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Morgan, et al., "The Use of a Novel Microreactor for High Throughput Continuous Flow Organic Synthesis," Sensors and Actuators B-Chemical, 2000, 63, p. 153.</td> </tr> <tr> <td data-bbox="256 596 695 646"></td> <td data-bbox="695 596 1487 646">Burns et al., "Development of a Microreactor for Chemical Production," AIChE 2<sup>nd</sup> International Conference on Microreaction Technology, pp. 39-44 (1998)</td> </tr> <tr> <td data-bbox="256 646 695 697"></td> <td data-bbox="695 646 1487 697">Cooke, "Decreasing Gas Chromatography Analysis Times using a Multicapillary Column," Abs. 403P, Book of Abstracts, PittCon '96 (1996)</td> </tr> <tr> <td data-bbox="256 697 695 747"></td> <td data-bbox="695 697 1487 747">Ehrfeld et al., "Potentials and Realizations of Microreactors," DECHEMA Monographs Vol. 132, pp. 1-28 (1995)</td> </tr> <tr> <td data-bbox="256 747 695 798"></td> <td data-bbox="695 747 1487 798">Hanak et al., "Optimization Studies of Materials in Hydrogenated Amorphous Silicon Solar Cells," Photovoltaic Solar Energy Conference, Berlin (1979)</td> </tr> <tr> <td data-bbox="256 798 695 848"></td> <td data-bbox="695 798 1487 848">Honnicke et al., "Heterogeneously Catalyzed Reactions in a Microreactor," DECHEMA Monographs Vol. 132, pp. 93-107 (1995)</td> </tr> <tr> <td data-bbox="256 848 695 898"></td> <td data-bbox="695 848 1487 898">Johansson et al., "Nanofabrication of Model Catalysts and Simulations of their Reaction Kinetics," J. Vac. Sci. Technol., 17:1 (Jan/Feb 1999)</td> </tr> <tr> <td data-bbox="256 898 695 949"></td> <td data-bbox="695 898 1487 949">Löwe et al., "Microreactor Concepts for Heterogeneous Gas Phase Reactions," AIChE 2<sup>nd</sup> International Conference on Microreaction Technology, pp. 63-73 (1998)</td> </tr> <tr> <td data-bbox="256 949 695 999"></td> <td data-bbox="695 949 1487 999">Matlosz et al., "Microsectioned Electrochemical Reactors for Selective Partial Oxidation," AIChE 2<sup>nd</sup> International Conference on Microreaction Technology, pp. 54-59 (1998)</td> </tr> <tr> <td data-bbox="256 999 695 1050"></td> <td data-bbox="695 999 1487 1050">S.M. Sze, "Semiconductor Sensors," Chap. 2, pp.17-96, John Wiley &amp; Sons, Inc. (1994)</td> </tr> <tr> <td data-bbox="256 1050 695 1100"></td> <td data-bbox="695 1050 1487 1100">Srinivasan et al., "Micromachined Reactors for Catalytic Partial Oxidation Reactions," AIChE Journal, Vol. 43, No. 11, pp. 3059-3069 (1997)</td> </tr> <tr> <td data-bbox="256 1100 695 1150"></td> <td data-bbox="695 1100 1487 1150">Tonkovich et al., "The Catalytic Partial Oxidation of Methane in a Microchemical Reactor," AIChE 2<sup>nd</sup> International Conference on Microreaction Technology, pp. 45-53 (1998)</td> </tr> <tr> <td data-bbox="256 1150 695 1201"></td> <td data-bbox="695 1150 1487 1201"><del>van den Berg et al., "Modular Concept for Miniature Chemical Systems," DECHEMA Monographs Vol. 132, pp. 109-123 (1995)</del></td> </tr> <tr> <td data-bbox="256 1201 695 1251"></td> <td data-bbox="695 1201 1487 1251">van Dover et al., "Discovery of a Useful Thin-Film Dielectric Using a Composition-Spread Approach," Nature, Vol. 392, No. 12, pp. 162-164 (1998)</td> </tr> <tr> <td data-bbox="256 1251 695 1302"></td> <td data-bbox="695 1251 1487 1302">Bunshah, "Handbook of Deposition Technologies for Films and Coatings," 2<sup>nd</sup> Ed., Noyes Publications (1994)</td> </tr> </table>					G.M. 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